



EUVL Workshop

Announcements

Thursday, June 13, 2019



Announcements

- **Workshop Proceedings**

- PDF version of presentations will be published in the proceedings after July 15th.
- If you have not submitted a PDF version of your presentation, we will make a PDF for you it.
- If you have animation, please make your own PDF.
- **If you need to make changes to your presentation, please send me revised PDF version no later than end of moth (Friday, June 28th)**

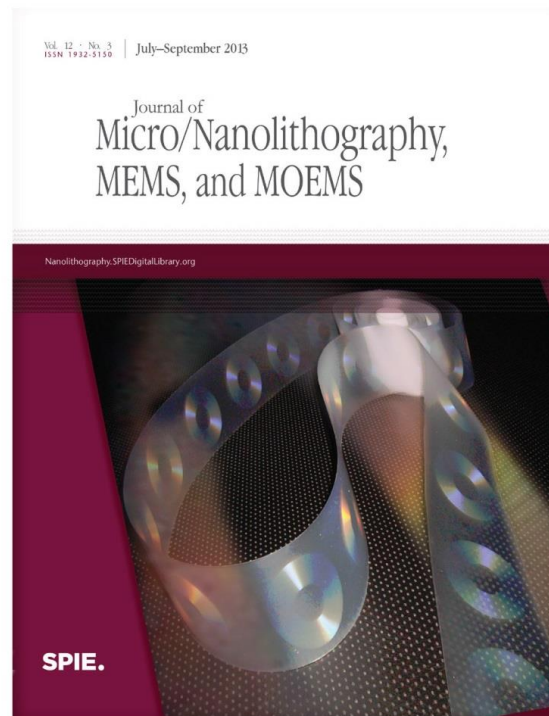
- **2019 EUVL Workshop Summary will be posted on the website as part of the workshop proceedings**

- **Highlights from the meetings will also be published under blog at www.euvlitho.com**



SPIE

Submit your work to the *Journal of Micro/Nanolithography, MEMS, and MOEMS*



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2019 Source Workshop

November 4-6, 2019, Amsterdam, The Netherlands



2020 EUVL Workshop

June 8-11, 2020, CXRO, LBL, Berkeley, CA, USA

Thanks!

- I will like to thank following for making 2019 EUVL Workshop a success!
 - Workshop Sponsors – Financial support
 - EUVL Workshop Steering Committee – Guidance and Agenda Preparation
 - Session Chairs and Presenters - Organization
 - Patrick Naulleau and CXRO for hosting the workshop!
 - Stuart Sherwin, Luke Long, Leia Naulleau and Jonathan Ma for their execution of the workshop
 - **Juanita Spencer for the great organization!**